

IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

**PATENT APPLICATION**

Applicant: **Seutter et al.** ✓

Case: **5192 USA/ISM/CORE MCVD/BG**

Serial No.: **09/776,329** ✓

Filed: February 2, 2001 ✓

Group Art Unit: **2822**

Examiner: **Toniae M. Thomas** ✓

Title: **FORMATION OF A TANTALUM-NITRIDE LAYER**

COMMISSIONER FOR PATENTS  
Washington, DC 20231

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TECHNOLOGY CENTER 2800

S I R:

**RESPONSE TO RESTRICTION REQUIREMENT**

In response to the Office Action dated October 21, 2002 (Paper No. 4) which imposed a restriction requirement in the above-captioned patent application, the applicants hereby elect Group I (Claims 1-28 and 32-47) drawn to a coating method, classified in class 427, subclass 255.394. Additionally, the applicants reserve the right to subsequently file divisional applications in order to prosecute the inventions recited in any one or more of the non-elected claims.

Respectfully,

11/11/02

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